

राष्ट्रीय प्रौद्योगि की संस्थान सिलचर National Institute of Technology Silchar

(राष्ट्रीय महत्व का संस्थान)

(An Institute of National Importance)

www.nits.ac.in, Phone: 03842-242914, Fax: 03842-224797, Assam-788010 (INDIA)

Advertisement No.: NITS/Dean(R&C)/Physics/694/01/2025

Date: 27-05-2025

Applications are invited from Indian citizens for a temporary of post of **Junior Research Fellow** for the ANRF sponsored project in the Department of Physics NIT Silchar.

1 1)	1			
Title of the project	Type ABO ₃ (A = Mg, Ba, Sr, Ca and B = Ti, Zr) based high entropy			
	ceramics for next generation energy storage applications			
Sponsored Agency	Anusandhan National Research Foundation (ANRF)			
Project sanction number	ANRF/IRG/2024/000134/PS			
No. of posts	One (01)			
Duration	Three (03) years (extension based on performance review every 12			
	months)			
Principal Investigator (P.I)	Dr. Susmita Rabha, Assistant professor, Department of Physics, National			
	Institute of Technology Silchar, Assam-788010.			

General Information and Terms & Conditions

	eneral information and Terms & Col	
	· ·	28 years (preferably)
	Essential Qualification	MSc. in Physics
3.	Desirable Experience	Practical experience in experimental condensed matter
		physics.
		 Excellent analysis and report writing skill.
		 Proficiency in using graph plotting software and Microsoft
		office software.
4.	Salary	Rs. 37,000/- p.m. for candidates with NET/GATE
		qualification. HRA @10% if Institute Accommodation is not
		provided.
5.	Relaxation on qualification and age	SC/ST/OBC/WOMEN/PWD candidates will get
	1	relaxation as per Govt of India Rules.
6.	Last date of receiving/ submission	13.06.2025
	of filled up application form	
	Reporting	Applicants are requested to submit their filled-up applications
		along with C.V. to the P.I. accompanying photocopies of all
		documents. Applicants are also requested to send the soft
		copy of the duly filled application along with C.V. & all
		necessary documents to the P.I through email:
		susmita@phy.nits.ac.in
9.	Date of interview, time, and venue	Date, time and venue will be notified to shortlisted
'	bate of fitterview, time, and venue	candidates.
10	No objection certificate	Employed candidates are to submit no objection certificate
10.		from his/her employer at the time of interview.
11	Instituto right	The Institute has the discretion to restrict the number of
11.	Institute right	
		candidates to be called for the interview on the basis of
		screening. No candidate may be recruited if suitable
10		candidates are not found.
12.	Signing of the agreement	Selected candidates shall have to sign an agreement at the
		time of joining.

Sd/-

Associate Dean (R&C)

NIT Silchar.

National Institute of Technology Silchar <u>FORMAT of APPLICATION</u> For **Junior Research Fellow**

Paste recent passport size colored photograph

	Exam.	Board/ University	Division	% age	Year of	Subjects
13.	13. Educational Qualification: (Starting from Class X)					
12.	. Whether be	elongs to SC/ST/OB	C: (If yes, a	ttach certifica	te):	
11.	. Marital Sta	tus:				
10.	10. Nationality:					
9.	Permanent	Address:				
	E-mail:			Phone	no.:	
8.	Postal Add	ress:				
7.	Age as on 1	13.06.2025:				
6.	Date of Bir	th (DD-MM-YYYY):				
5.	Mother's N	Jame:				
4.	Father's Na	ame:				
3.	Name of th	e applicant (in block	(letters):			
2.	Departmen	nt:				
1.		nent no Project				

Exam. passed	Board/ University	Division	% age Of marks/ CPI	Year of passing	Subjects

14. Research	Experience:
--------------	-------------

Sl. No.	Research Topic	Sponsor	Period	Designation	Nature of duty

15. Details of previous/current employments:

S1. No.	Name of the Organization	Name of the post	Period	Scale of pay and present pay	Nature of duty

16. Any other relevant information that you may like to furnish:

Declaration

belief.	I declare that the above information are true and correct to the best of my knowledge and
Date:	
Place	Signature of the applicant